Notice of References Cited Application/Control No. 10/762,621 Examiner Gabriel L. Chu Applicant(s)/Patent Under Reexamination HADLEY ET AL. Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0093608	05-2003	Jaramillo et al.	710/310
*	В	US-5,317,757	05-1994	Medicke et al.	712/229
*	С	US-5,539,680	07-1996	Palnitkar et al.	703/13
*	D	US-5,623,499	04-1997	Ko et al.	714/724
*	Е	US-5,703,885	12-1997	Sun et al.	714/738
*	F	US-5,910,958	06-1999	Jay et al.	714/738
*	G	US-5,913,023	06-1999	Szermer, Wojciech	714/38
*	Н	US-5,966,516	10-1999	De Palma et al.	703/1
*	ı	US-6,002,869	12-1999	Hinckley, David N.	717/124
*	J	US-6,546,507	04-2003	Coyle et al.	714/43
*	К	US-6,675,244	01-2004	Elliott et al.	710/107
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 10021286 A	01-1998	Japan	Iwasaki	G06f017/50
	0					
	Р					
	Q					
	R					
	s					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	υ	Friedman et al., "Projected State Machine Coverage for Software Testing", 2002, ACM.
	V	Microsoft Press Computer Dictionary Third Edition, "block size", Microsoft Press, 1997, pg. 56.
	w	
	x	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.